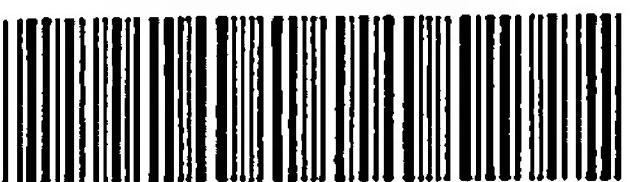


<b>Search Notes</b>		<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
		10/604,641	PONZIO, MASSIMO
		Examiner	Art Unit
		José V. Chen	3637

<b>SEARCHED</b>			
Class	Subclass	Date	Examiner
100	55.1 55.3	3/22/06	JVC
	51.11		
198	803.01		
264	56 55 292		
		10/17/06 JVC	

<b>SEARCH NOTES (INCLUDING SEARCH STRATEGY)</b>		
	<b>DATE</b>	<b>EXMR</b>
Patent Sources Prior Art	3/22/06	JVC
PTA Cos	10/17/06	JVC
UDATOS	4/16/07	JVC

<b>INTERFERENCE SEARCHED</b>			
Class	Subclass	Date	Examiner